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PRI ICA TION NO	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/032,564	01/02/2002	Yasutoshi Okuno	740819-725	5824
22201	590 04/03/2003		EXAM	INER
NIXON PEAI 8180 GREENS SUITE 800	IN PEABODY, LLP GREENSBORO DRIVE ESTRADA, MICHELLE GROO		MICHELLE	
MCLEAN, VA	22102		ART UNIT	PAPER NUMBER
			2823	

DATE MAILED: 04/03/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

<u> </u>		Application No.	Applicant(s)
• .		10/032,564	OKUNO ET AL.
	Office Action Summary	Examiner	Art Unit
ا		Michelle Estrada	2823
/	The MAILING DATE of this communication	on appears on the cover sheet	with the correspondence address
Daried fo	- Panly		
A SHO THE N - Exter after - If the - If NO - Failu	ORTENED STATUTORY PERIOD FOR F MAILING DATE OF THIS COMMUNICAT asions of time may be available under the provisions of 37 SIX (6) MONTHS from the mailing date of this communical period for reply specified above is less than thirty (30) day o period for reply is specified above, the maximum statutory are to reply within the set or extended period for reply will, be reply received by the Office later than three months after the ad patent term adjustment. See 37 CFR 1.704(b).	CFR 1.136(a). In no event, however, may lion. s, a reply within the statutory minimum of to period will apply and will expire SIX (6) M	a reply be timely filed hirty (30) days will be considered timely. ONTHS from the mailing date of this communication. ARANDONED (35 U.S.C. § 133).
1)⊠	Responsive to communication(s) filed of	on <u>03 January 2003</u> .	
2a)□	This action is FINAL 2b)	This action is non-final.	
3)□	e e to to annuition for	allowance except for formal runder Ex parte Quayle, 1935	matters, prosecution as to the merits is C.D. 11, 453 O.G. 213.
4112	Claim(s) 1-10 is/are pending in the app	lication.	
7/63	4a) Of the above claim(s) is/are v	vithdrawn from consideration.	
5)□	ومستوال والمستوال		
1 ,—	Claim(s) <u>1-10</u> is/are rejected.		
	Claim(s) is/are objected to.		
ار ا	Claim(s) are subject to restriction	n and/or election requirement.	
	tion Papers		
مر ا	The specification is objected to by the E	xaminer.	
10)	The drawing(s) filed on is/are: a)	accepted or b) objected to	by the Examiner.
		ion to the drawing(s) be held in a	beyance. See 37 Of It 1.00(4).
11)	The proposed drawing correction filed o	n is: a)[_] approved b)	gisapproved by the Examiner.
	If approved, corrected drawings are requi	red in reply to this Office action.	
12)[The oath or declaration is objected to b	y the Examiner.	
Driorit	under 35 H S C. 88 119 and 120		(A) (A) (A)
13)	Acknowledgment is made of a claim for	or foreign priority under 35 U.S	S.C. § 119(a)-(d) or (t).
	a) ☐ All b) ☐ Some * c) ☐ None of:		
	1 Cortified copies of the priority de	ocuments have been received	l.
	a Contified copies of the princity de	ocuments have been received	I in Application No
	3. Copies of the certified copies of application from the Interna	the priority documents have tonal Bureau (PCT Rule 17.2) for a list of the certified copie:	been received in this National Stage (a)). s not received.
14)	Acknowledgment is made of a claim for	r domestic priority under 35 U	.S.C. § 119(e) (to a provisional application
	a) The translation of the foreign lang Acknowledgment is made of a claim for	wage provisional application i	192 Deell leceived.
Attachr			erview Summary (PTO-413) Paper No(s)
	Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PT nformation Disclosure Statement(s) (PTO-1449) Pa	rO-948) 5) 🔲 No	tice of Informal Patent Application (P10-152)

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DETAILED ACTION

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 1/3/03 has been entered.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-10 are rejected under 35 U.S.C. 103(a) as being unpatentable over the combination of Choi et al. (6,168,991) and Moise et al. (6,534,809).

Choi et al. disclose a method for fabricating a semiconductor device including a concaved capacitor device having a lower electrode (20), a capacitor dielectric film (22) of a perovskite type high dielectric constant or ferroelectric material formed on said lower electrode and an upper electrode (26) formed on said capacitor dielectric film, comprising a step of: forming a conducting film to be formed into said lower electrode including sub-steps of: depositing a lower conducting (20) film by sputtering on walls

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and a bottom of a recess formed in an insulating film (12) on a substrate (10); and depositing an upper conducting film (26) on said lower conducting film by CVD (See Col. 4, lines 47-51 and Col. 6, lines 22-32); wherein said lower conducting film has a thickness of approximately 300Å to 500 Å; wherein said capacitor device is a stacked capacitor device; wherein the CVD could be carried out in an oxidizing atmosphere, because the materials of the upper electrode could be oxides (Col. 5, lines 14-17).

Choi et al. does not disclose depositing the upper conducting film directly on and in contact with said lower conducting film.

Moise et al. disclose forming a stack bottom electrode (124) comprising a metal layer and a conductive oxide formed directly on and in contact with the metal layer (Col. 9, lines 30-35; forming a stack top electrode comprising a stack of a conductive oxide (128) and a metal layer (130) formed directly on and in contact with the conductive oxide (128) (Col. 10, lines 27-34).

It would have been within the scope of one of ordinary skill in the art to combine the teachings of Choi et al. and Moise et al. to enable formation of the capacitor electrodes.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Michelle Estrada whose telephone number is (703) 308-0729. The examiner can normally be reached on Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 703-306-2794. The fax phone numbers

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for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

George Fourson
Primary Examiner
Art Unit 2823

MEstrada

March 25, 2003